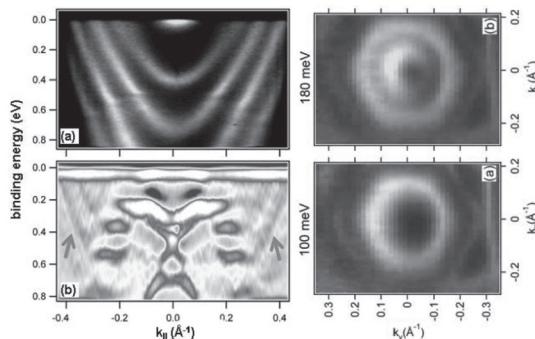
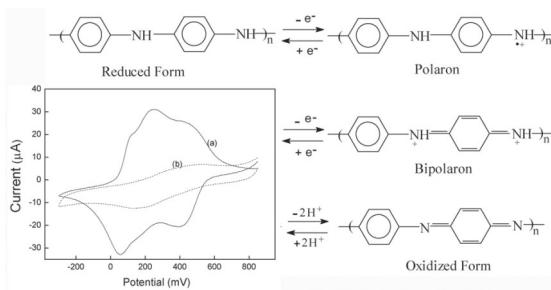
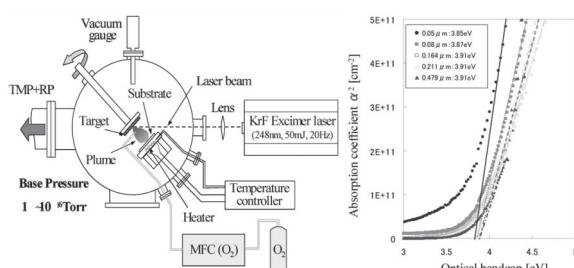
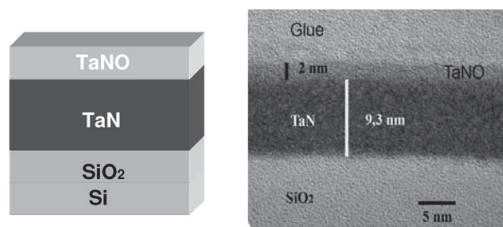
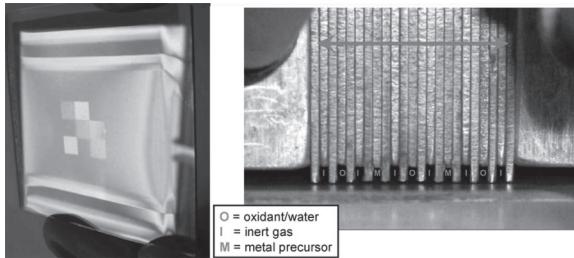
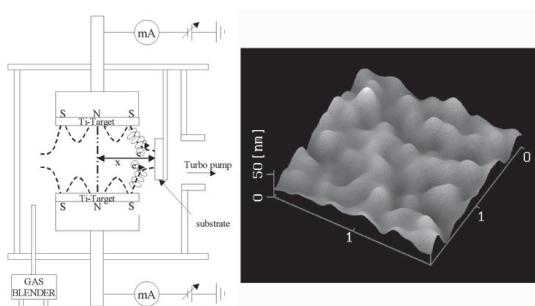
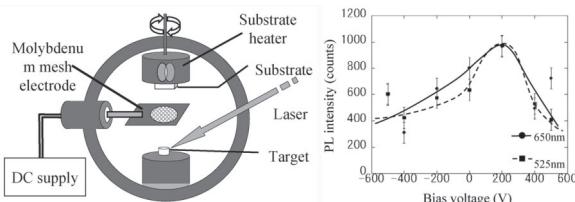
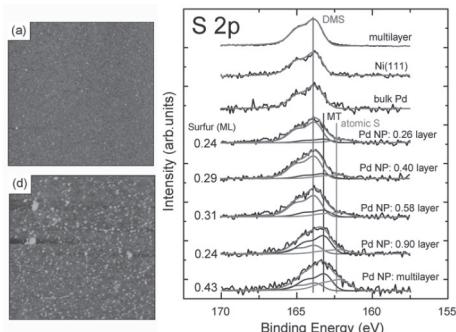


ホームページ：<http://www.sssj.org/ejssnt> 電子メール：[ejssnt@sssj.org](mailto:ejssnt@sssj.org)J-Stage アーカイブ：<http://www.jstage.jst.go.jp/browse/ejssnt/>**非磁性の表面合金相でスピン分裂バンド****New Mechanism for Spin-Orbit Splitting of Conduction States in Surface Alloys (Conference-ICSFS-14-)***E. Frantzeskakis, L. Moreschini, M. C. Falub, M. Grioni, S. Pons, C. R. Ast, D. Pacile, and M. Papagno,  
Vol. 7, pp. 264-268 (4 April, 2009)***導電性ポリマーの抗酸化剤作用****Structural changes in polyaniline upon reaction with DPPH (Conference-ICSFS-14-)***C. F. Hsu, H. Peng, L. Zhang, J. Travas-Sejdic, and P. A. Kilmartin, Vol. 7, pp. 269-272 (4 April, 2009)***紫外線に対して透明な導電性薄膜****Properties of amorphous transparent conductive In-Ga-Zn oxide films deposited on fused quartz by the PLD method (Conference- ICSFS-14-)***K. Tominaga, T. Tsuzuki, T. Maruyama, M. Mikawa, and T. Moriga, Vol. 7, pp. 273-276 (4 April, 2009)***CMOS ゲート電極金属としての TaN 膜****Properties of TaN Thin Films Produced Using PVD Linear Dynamic Deposition Technique (Conference- ICSFS-14-)***Vol. 7, pp. 277-283 (4 April, 2009)  
M. Kozlowska, R. Oechsner, M. Pfeffer, A. J. Bauer, E. Meissner, L. Pfitzner, H. Ryssel, W. Maass, J. Langer, B. Ocker, S. Schmidbauer, and J.-P. Gonchond***ALD (原子層堆積法) でガーフィルターレイを作る  
Fabrication of a Patterned Interference Filter Array****Deposited by an Atmospheric Pressure Vapour Deposition Technique (Conference-ICSFS-14-)***J. R. Fyson, Zs. Nagy, and C. L. Bower***光触媒活性の酸化チタン薄膜をスパッタリングで堆積****Deposition of photocatalytic TiO<sub>2</sub> films using a planar magnetron sputtering system with opposed Ti targets (Conference-ICSFS-14-)***K. Tominaga, K. Okada, Y. Miyamoto, S. Ohkura, K. Shiraishi, K. Kusaka, T. Ueno, and T. Hanabusa, Vol. 7, pp. 290-293 (4 April, 2009)*

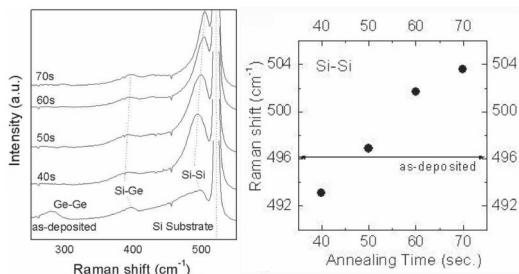
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*T. Komiyama, K. Iwataki, H. Yamaguchi, T. Aoyama, Y. Kashiwaba, and H. Taniguchi*



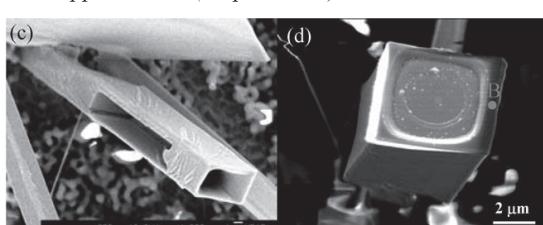
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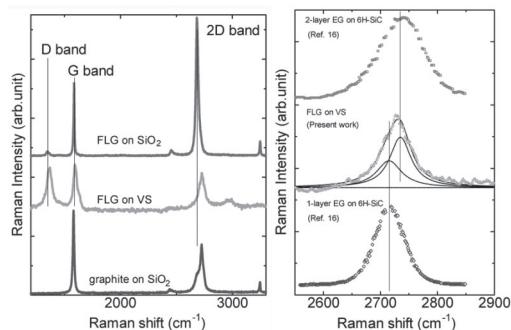
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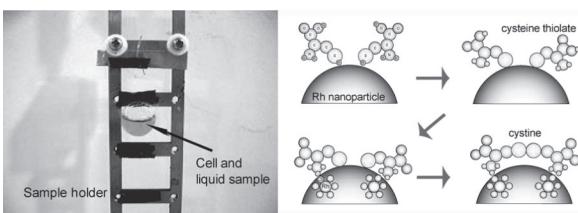
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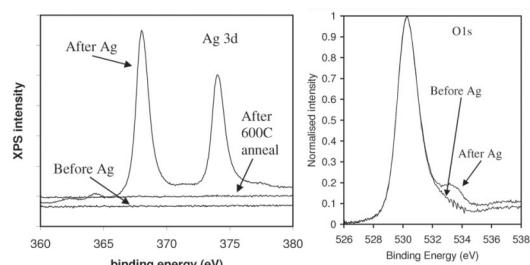
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